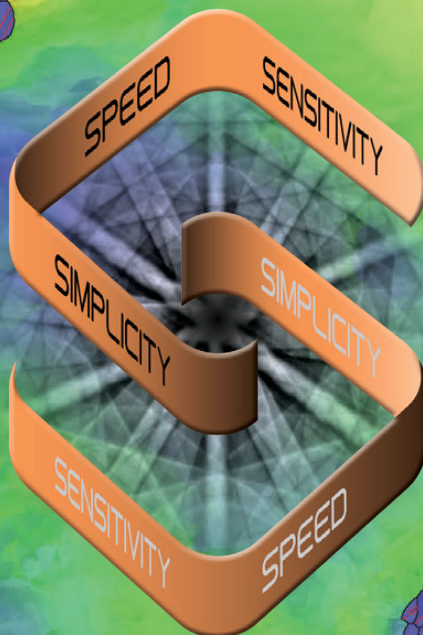


SYMMETRY[®] EBSD Detector

An order of magnitude performance improvement



CMOS speed, **CMOS** sensitivity, no compromise



The Business of Science[®]

SYMMETRY

A technology breakthrough

Symmetry, the world's first EBSD detector based on CMOS sensor technology, is set to revolutionise EBSD analysis.

Operating at over 3,000 indexed patterns per second (pps), Symmetry balances unprecedented speed with exceptional sensitivity to enable work even at low beam currents and voltages.

All of this is delivered within a design that provides perfect operational simplicity. Now you can use a single detector for all applications - with no compromise.

CMOS speed, **CMOS** sensitivity, no compromise



Operating at over 3000 patterns per second, Symmetry is the world's fastest EBSD detector. This step-change in performance delivers not only for routine applications, but also for large area mapping, 3D EBSD and *in situ* experiments.



With unparalleled sensitivity and dynamic range, Symmetry is ideal for even the most challenging applications, where low beam currents coupled with fast, high-resolution patterns are a necessity. Now there's no compromise between speed and sensitivity.



One detector fits all applications: features such as variable tilt, dynamic calibration, automated set-ups and seamless EDS integration ensure that everyone will get the right results every time.



Symmetry is a game-changer. Its unprecedented all-round performance will open up exciting new developments in even the most exacting of applications.

Breakthrough technology

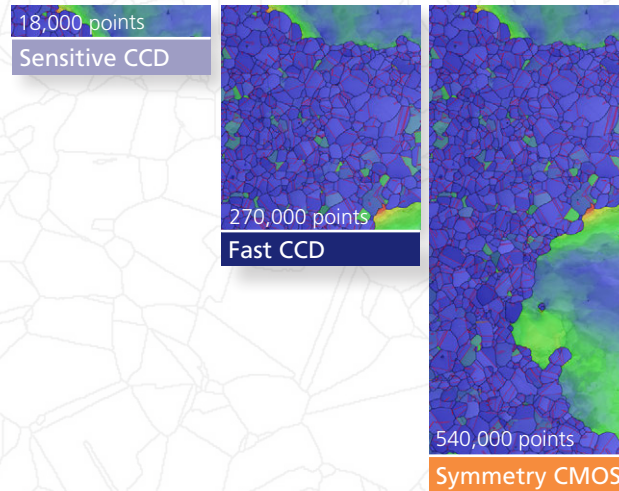
CMOS-based cameras can be both fast and sensitive and are already making a significant impact in other technology fields.

Symmetry incorporates a customised CMOS image sensor, optimised for EBSD.

It enables a level of performance never achieved by any previous EBSD detector.

Whether the focus is on speed or sensitivity, there is no need for compromise.

...up to 30x more data collected in the same time.



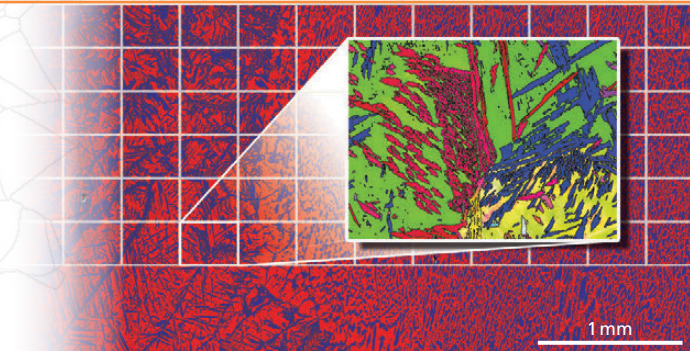
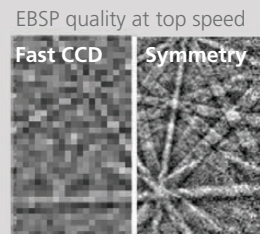
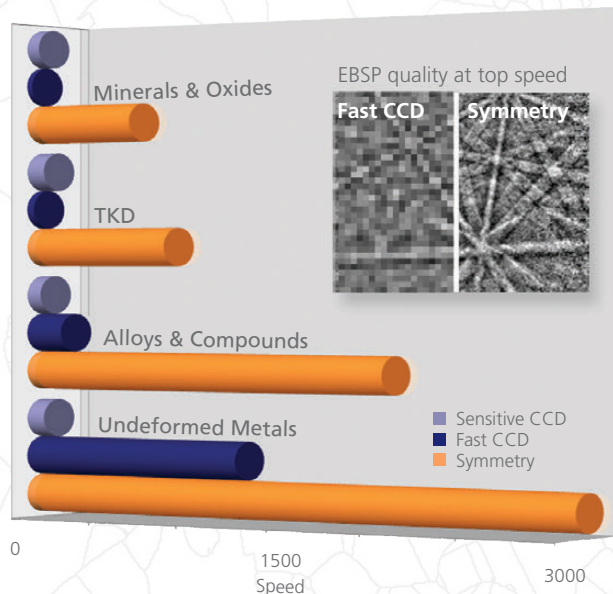
The 'one choice - no compromise' detector

The unrivalled combination of speed and sensitivity of Symmetry ensures the best performance across a complete range of samples.

High acquisition speeds can be achieved without any loss of data quality.

Symmetry's high sensitivity means that, even on more challenging samples such as complex oxides or thin films, an order of magnitude increase in acquisition speed may be achieved with the best possible data quality.

...the best performance on *all* types of sample



Large area phase map of a weld margin in a duplex stainless steel, with zoomed IPF map showing the actual resolution. Sample was ~5 mm x 3 mm and 50,000,000 points were collected at 2000 pps.

3D EBSD

The unparalleled 3000 pps acquisition speed makes Symmetry the ideal detector for data-intensive 3D EBSD analyses on FIB-SEMs, typically saving many hours in a single 3D experiment.

In situ analysis

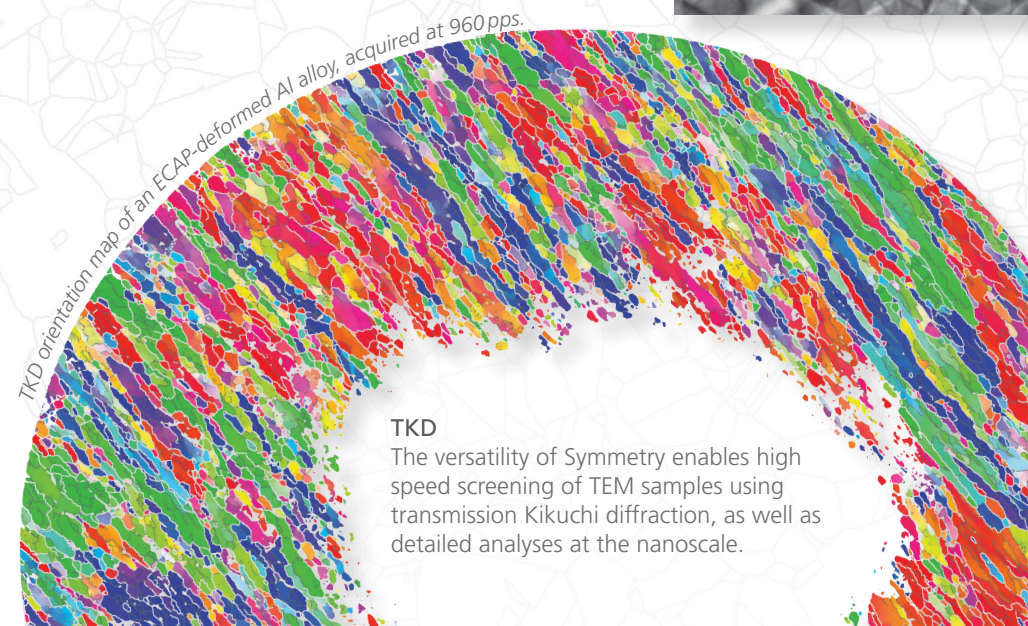
During dynamic heating and tensile experiments transformations can occur in seconds. Only Symmetry captures these changes in real-time.

Large Area Mapping

Required for accurate grain size determination or texture measurements where there is a need to cover a valid number of grains. Now, large areas with many hundreds of fields can be covered up to 10x faster.

HR EBSD for strain determination

Symmetry is optimised for strain and defect analyses. It combines distortion-free imaging, high pattern resolution and superb sensitivity.



TKD

The versatility of Symmetry enables high speed screening of TEM samples using transmission Kikuchi diffraction, as well as detailed analyses at the nanoscale.

Operational simplicity

Megapixel screen resolution

Optimised for HR-EBSD strain analysis and accurate phase studies.

Optimised phosphor screen

For best performance across all applications.

156 x 128 pixel resolution at top speed

Perfect indexing and exceptional angular resolution at speeds over 3000 pps.

IR filter

Suitable for high temperature *in situ* experiments.

Five integrated FSDs

Provide full colour complementary Z-contrast and channelling contrast images.

Contactless collision detection

Proximity-based alarm senses potential collisions before they happen.

Low kV operation
Achieve the highest spatial resolution.

Seamless EDS integration

Simultaneous chemical and crystallographic mapping at all acquisition speeds.

Flexible

Operates in both transmission and conventional (backscattered) modes.

Intuitive camera configuration

For reliable and robust acquisition conditions and best results.

Software-controlled tilting interface

Flexible detector geometry to suit every application.

Autocalibration

Flawless indexing at any detector tilt or insertion position.

Bellows SEM interface

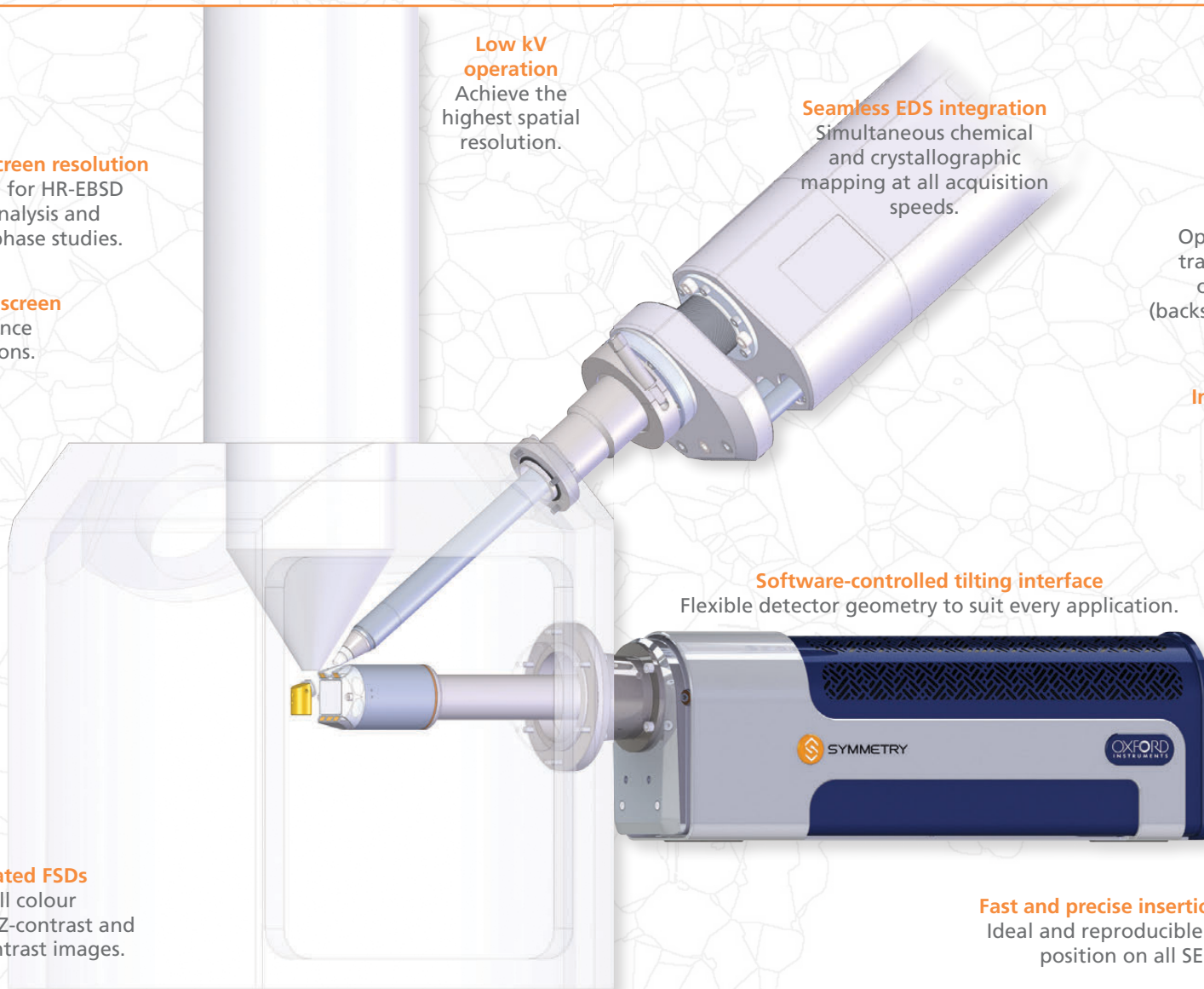
Maintains the microscope's vacuum integrity for the lifetime of the detector.

Fast and precise insertion control

Ideal and reproducible detector position on all SEMs.

Advanced high efficiency optics

High quality patterns at low doses for maximum spatial resolution.





We are renowned for delivering outstanding support. Our global service hubs offer a full range of technical support to keep your detector, system and staff at maximum efficiency.



Keep your investment at peak performance. Multi-layered maintenance contracts suit your operational needs and budget.



Optimising you. Optimising your team. Omni-channel training enables everyone to deliver the right results every time.



Our global network of help desks guarantee a fast *local* expert response to any application or operational issue.



Our team of accredited support professionals proactively ensure your system is in optimal condition.



We're with you every step of the way to future proof your investment and ensure onwards data and system compatibility.

This brochure provides a glimpse into the revolutionary capabilities of the Symmetry EBSD detector. Significantly more detail, including in-depth application notes, videos and technical overviews, can be found on our website at:

www.oxinst.com/symmetry

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